

Form PTO-1449		Application Number <u>10/663,001</u> Not Yet Assigned		Inventor Martin Schmidt et al		
INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)		Title OPERATING-MICROSCOPE SYSTEM				
		Filing Date <u>9/16/03</u> Not Yet Assigned	Group Art Unit <u>2872</u> Not Yet Assigned	Docket Number GMH/409/US		
UNITED STATES PATENT DOCUMENTS						
EXAMINER # INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<u>W07</u>	5,704,900	01/1998	Dobrovoly et al.	600	229	
<u>N07</u>	2002/0026096 A1	02/2002	Motoki et al.	600	146	
FOREIGN PATENT DOCUMENTS						
DOCUMENT NUMBER	DATE MO/DAY/YR	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
					YES	NO
<u>W07</u> DE 23 19 215	1973	Germany	_____	_____		X
<u>W07</u> DE 43 11 467 A1	1994	Germany	_____	_____		X
<u>W07</u> DE 195 21 060 A1	1996	Germany	_____	_____		X
<u>W07</u> DE 196 32 281 A1	1997	Germany	_____	_____		X
<u>W07</u> DE 196 40 907 A1	1997	Germany	_____	_____		X
<u>W07</u> 2001-46399	2001	Japan	_____	_____		X
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)						
		International Search Report EP 02 02 0833, Dated 12 December 2002.				
<u>W07</u>		Patent Abstract of Japan, Title: Microscopic Device For Operation, Publication No. 2001046399, Dated 20-02-2001.				
<u>W07</u>		Patent Abstract of Japan, Title: System Controller, Publication No. 2002125219, Dated 26-04-02.				
EXAMINER		<u>W07</u>		DATE CONSIDERED		<u>10/5/05</u>
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.						

Examiner
Zwihl